

10/576499
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Customer No. 22,852
Attorney Docket No. 02386.0103

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: **Lars MONTELIUS et al.**)
Application No.: Not Yet Assigned)
Filed: **April 20, 2006**) Group Art Unit: Not Yet Assigned
National Stage of International Application No.)
PCT/EP2004/052656 under 35 U.S.C. 371) Examiner: Not Yet Assigned
For: **APPARATUS AND METHOD FOR**)
ALIGNING SURFACES)

MAIL STOP PCT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. § 1.97(b)

Pursuant to 37 C.F.R. §§1.56 and 1.97(b), applicants bring to the Examiner's attention the documents listed on attached Form PTO/SB/08 and cited in the international search report. With the exception of the U.S. patents, a copy of each listed document is attached. Applicants respectfully request that the Examiner consider the documents listed on attached Form PTO/SB/08 and indicate that they were considered by making an appropriate notation on this form.

This Information Disclosure Statement is being filed with the above-referenced application.

Also enclosed is an English-language international search report from the European Patent Office in the PCT international application, from which this national phase U.S. application is derived.

This submission does not represent that a search has been made or that no better art exists and does not constitute an admission that each or all of the listed documents are material or constitute "prior art." If the Examiner applies any of the documents as prior art against any claim in the application and applicants determine that the cited documents do not constitute "prior art" under United States law, applicants reserve the right to present to the Office the relevant facts and law regarding the appropriate status of such documents. Applicants further reserve the right to take appropriate action to establish the patentability of the disclosed invention over the listed documents, should one or more of the documents be applied against the claims of the present application.

If there is any fee due in connection with the filing of this Statement, please charge the fee to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: April 20, 2006

By:


Ernest F. Chapman
Reg. No. 25,961

Enclosures
EFC/FPD/blc

IDS Form PTO/SB/08: Substitute for form 1449A/PTO				Complete if Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>				Application Number	Not Yet Available
				Filing Date	April 20, 2006
				First Named Inventor	Lars MONTELIUS
				Art Unit	Not Yet Available
				Examiner Name	Not Yet Available
Sheet	1	of	1	Attorney Docket Number	02386.0103

U.S. PATENTS AND PUBLISHED U.S. PATENT APPLICATIONS					
Examiner Initials	Cite No. ¹	Document Number	Issue or Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
		US-2004/0022888	02-05-2004	Sreenivasan et al.	
		US 2003/0128361	07-10-2003	Kurodá et al.	
		US-5,722,905	06-30-1998	Chou	
		US-6,628,392	09-30-2003	Kuroda et al.	

Note: Copies of the U.S. Patent Documents are not Required in IDS filed after October 21, 2004

FOREIGN PATENT DOCUMENTS					
Examiner Initials	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)			
		WO 99/15933	04-01-1999	Biebuyck et al.	

NON PATENT LITERATURE DOCUMENTS					
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.			Translation ⁶
		WHITE et al., "Novel Alignment System for Imprint Lithography", XP-002204287, J. Vac. Sci. Technol. B 18(6), pp. 3552-3556, (2000).			
		CHOI et al., "Layer-To-Layer Alignment for Step and Flash Imprint Lithography", XP-002275988, Proceedings of SPIE, Vol. 4343, pp. 436-442, (2001).			

Examiner Signature		Date Considered
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.